

Application/Control No.	Applicant(s)/Patent under Reexamination
09/866,008	KIM, KI HO
Examiner	Art Unit

Samson B. Lemma

2132

SEARCHED					
Class	Subclass	Date	Examiner		
380	37	6/23/2005	SL		
380	236	6/23/2005	SL.		
380	283	6/23/2005	SL		
380	257	6/23/2005	SL		
380	270	6/23/2005	SL		
704	270.1	6/23/2005	SL		
370	479	6/23/2005	SL .		
713	171	6/23/2005	SL		
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INTERFERENCE SEARCHED					
Class	Subclass	Date	Examiner		
380	270	6/23/2005	SL		
704	270.1	6/23/2005	SL		
380	283	6/23/2005	SL		
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SEARCH NOTES (INCLUDING SEARCH STRATEGY)				
	DATE	EXMR		
Updated East KeyWord Search	6/23/2005	SL		
NPL (IEEE AND ACM DIGITAL LIBRARY, Google and CiteSeer)	6/23/2005	SL		
Inventors Name Search (All the applicant application on the record have been examined for double patent rejection)	6/23/2005	SL		
Consulted With SPE Mr. Gilberto Barron	6/23/2005	SL		